

IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant(s): **Nguyen, et al.**

Case: **5619/DD/LOW K/JW**

Serial No.: **Not yet assigned**

Filed: **Herewith**

Group Art Unit: **Not yet assigned**

Title: **SELECTIVE ETCHING OF ORGANOSILICATE FILMS OVER  
SILICON OXIDE STOP ETCH LAYERS**

ASSISTANT COMMISSIONER OF PATENTS  
Washington, DC 20231

S I R:

Disclosure Statement under 37 C.F.R. 1.56 and 1.98

Pursuant to 37 C.F.R. 1.56, the documents (copies enclosed) listed on form PTO-1449, submitted herewith, are disclosed. Under rule 37 C.F.R. 1.98(a), the applicants submit that no specific comments are necessary for any of the cited English language publications having an enclosed English language translation or abstract.

June 26, 2001  
Date

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